

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant	)	
Migaku Takahashi	)	Art Group: 1753
Serial No.:	)	
Filing Date: September 18, 2003	)	
Title: MAGNETIC THIN FILM AND	)	Examiner: CANTELMO, GREGG
PRODUCTION METHOD THEREFOR	)	
	)	
	)	

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks  
Box: Patent Application  
Alexandria, VA 22313-1450

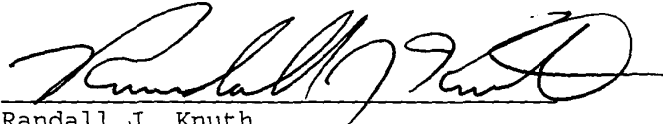
Sir:

In accordance with 37 C.F.R. § 1.56, Applicant wishes to bring to the attention of the Examiner the documents identified on the attached form PTO-1449. Applicant respectfully requests that these documents be made of record in the present application.

A copy of each of the documents is enclosed.

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

Respectfully submitted,



Randall J. Knuth  
Registration No. 34,644

RJK/mdc

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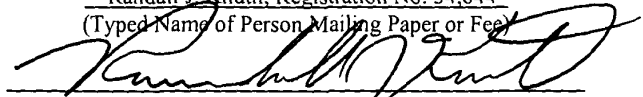
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Date of Deposit September 18, 2003.

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Enc. Form PTO-1449  
Cited Art References  
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Randall J. Knuth, Registration No. 34,644  
(Typed Name of Person Mailing Paper or Fee)



(Signature of Person Mailing Paper or Fee)

INFORMATION DISCLOSURE STATEMENT				Page <u>1</u> Of <u>1</u>			
				Atty. Docket No. FUK-12CPA		Serial No.	
				Applicant Migaku Takahashi			
				Filing Date September 18, 2003		Group 1753	
U.S. PATENT DOCUMENTS							
Examiner Initial *		Document No.	Date	Name	Class	Subclass	Filing Date
	AA	5,736,264	7/98	Ishiwata et al.	G11B	5/66	3/93
	AB	5,382,305	1/95	Terunuma et al.	H01F	10/00	8/93
	AC	5,173,370	12/92	Takahashi et al.	G11B	5/00	8/90
	AD	5,465,475	11/95	Kinoshita et al.	G11B	5/42	7/93
	AE	5,401,609	3/95	Haratani et al.	G11B	1/24	6/94
	AF	5,334,433	8/94	Tominaga	B32B	3/00	12/92
	AG	5,154,983	10/92	Watanabe	C22C	38/00	10/90
	AH	6,027,825	02/00	Shiratori et al	G11B	05/66	06/97
	AI	5,750,209	05/98	Samoto	H05H	01/24	09/96
	AJ	5,667,862	09/97	Nakane et al	G11B	05/66	04/91
	AK	5,659,537	08/97	Hirokane et al	G11B	07/00	06/95
	AL	5,687,045	11/97	Okai et al	G11B	05/31	11/95
FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subclass	Translation
							Yes      No
	AM	59-45911	3/84	Japan	C01B	21/06	3/82
	AN	62-164868	7/87	Japan	C23C	14/06	1/86
	AO	2-212320	8/90	Japan	C01G	49/00	2/89
	AP	61-148809	7/86	Japan	H01F	41/18	12/84
	AQ	62-285406	12/87	Japan	H01F	10/10	6/86
	AR	2-109309	4/90	Japan	H01F	10/14	10/88
	AS	60-25211	2/85	Japan	H01F	41/18	7/83
OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)							
	AT	<u>Journal of Applied Physics</u> 53 (11), November 1982. Pp. 8332-8334. "Metastable Fe Nitrides with High Bs Prepared by Reactive Sputtering". A. KANO, N.S. KAZAMA, H. FUJIMORI					
EXAMINER:				DATE CONSIDERED:			
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							